



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Steele et al.

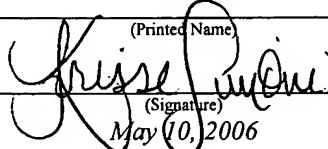
Title: WAFER INSPECTION SYSTEM

Appl. No.: 10/771,628

Filing Date: 02/03/2004

Examiner: Meagan S. Walling

Art Unit: 2863

CERTIFICATE OF MAILING	
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below.	
Krisse Simoni	
(Printed Name)	
	
(Signature)	
May 10, 2006	
(Date of Deposit)	

**AMENDMENT AND REPLY UNDER 37 CFR 1.111**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated January 11, 2006, concerning the above-referenced patent application.

Applicant has enclosed with this amendment a Petition for Extension of Time to make this response timely.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this document.

**Remarks/Arguments** begin on page 9 of this document.

Please amend the application as follows:

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